IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Yoshimi SHIOYA et al.

Serial No.: 10/530,730

Filed: September 29, 2005

For: SEMICONDUCTOR DEVICE
AND METHOD OF
MANUFACTURING SAME

Confirmation No. 4310

Art Unit: 1765

Examiner: DEO, Duy Vu Nguyen

DEO, Duy Vu Nguyen

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## AMENDMENT AND RESPONSE TO OFFICE ACTION OF MARCH 2, 2007

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the office action of March 2, 2007, please amend the captioned application as follows.